



17W  
Docket No.: 0756-7275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Hidekazu MIYAIRI, et al. )  
Serial No. 10/808,499 ) Group Art Unit: 2857  
Filed: March 25, 2004 ) Examiner: Jeffrey West  
For: METHOD FOR TESTING )  
SEMICONDUCTOR FILM, SEMICONDUCTOR )  
DEVICE AND MANUFACTURING METHOD )  
THEREOF )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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**REQUEST FOR STATUS**

Honorable Commissioner of Patents


P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

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